

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koji Naniwada

Application No. **10/565,222**

Filed: **January 20, 2005**

For: MEMS TYPE RESONATOR, PROCESS FOR
FABRICATING THE SAME AND
COMMUNICATION UNIT

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) Group Art Unit: **4177**
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) Examiner: **Eric R. Hamill**
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MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO JUNE 16, 2008 OFFICE ACTION

Dear Sir:

This Response is submitted in reply to the Office Action mailed June 16, 2008.

Applicant respectfully requests reconsideration of the application in view of the Amendment and
Remarks herein.